

Notice of References Cited	Application/Control No. 10/584,927		Applicant(s)/Patent Under Reexamination YAMAMOTO ET AL.	
	Examiner GUINEVER S. GREGORIO		Art Unit 1793	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0131787	07-2003	Linares et al.	117/93
	C	US-			
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	M	US-			

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	V	Landstrass et al. Device Properties of Homoepitaxially Grown Diamond; Diamond and Related Materials; 2, pages 1033-1037; 1993
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.